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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the U.S. Patent Application of

Yukiyasu SUGANO et al.

Serial No. 09/478,812

Filed: January 7, 2000

For: PROCESS FOR PRODUCING THIN FILM
SEMICONDUCTOR DEVICE AND
LASER IRRADIATION APPARATUS

Group Art Unit: 2825

Examiner: Unassigned

INFORMATION DISCLOSURE STATEMENTAssistant Commissioner for Patents
Washington, D.C. 20231

Sir:

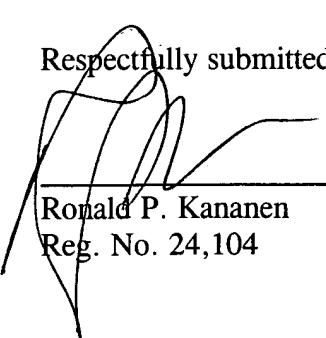
The Applicant, through its representatives and attorneys, hereby brings to the attention of the Examiner the document noted on the accompanying Form PTO-1449. A copy of the reference is provided for the Examiner's consideration.

The relevancy of this document is discussed in the original specification on page 7 of the above referenced application.

Please take this document into account in the initial examination of this application and make its consideration of record.

Dated: May 8, 2000

Respectfully submitted,


Ronald P. Kananen
Reg. No. 24,104

Rader, Fishman & Grauer PLLC
Suite 501
1233 20th Street, N.W.
Washington, D.C. 20036
Telephone: 202/955-3750
Facsimile: 202/955-3751